DATE OF DEPOSIT Oct 17, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Sumihito Morita et al.	
Serial No. To Be Assigned)
Filing Date: Herewith)
For: Thin Film Magnetic Head Having Partial Insulating Layer Formed on Bottom Pole Layer Through Gap Layer and Method of Manufacturing the Same)) Our File No. 9281-4709) Client No. N US03516)

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-identified application, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 6 of this paper.